

Notice of References Cited	Application/Control No. 10/088,620	Applicant(s)/Patent Under Reexamination RESCHNAR ET AL.	
	Examiner Edna Wong	Art Unit 1753	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,245,734	09-1993	Issartel, Jean-Paul	29/25.35
	B	US-			
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	D	US-			
	E	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

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*	N	DE 3402494 A1	07-1985	Germany	Siemens AG	C23C 20/04
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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